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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/722,495	11/28/2003	Yu-Kai Lin	BHT-3167-169	7679
DRUCE II TR	7590 09/21/2007		EXAM	INER
BRUCE H. TROXELL SUITE 1404 5205 LEESBURG PIKE FALLS CHURCH, VA 22041			WALFORD, NATALIE K	
			ART UNIT	PAPER NUMBER
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Applica	ation No.	Applicant(s)			
	10/722	, 4 95	LIN, YU-KAI			
Office Action Summary			Art Unit			
	Natalie	K. Walford	2879			
The MAILING DATE of this com Period for Reply	munication appears on t	he cover sheet with the d	correspondence address			
A SHORTENED STATUTORY PERION WHICHEVER IS LONGER, FROM THE Extensions of time may be available under the provafter SIX (6) MONTHS from the mailing date of this If NO period for reply is specified above, the maxim Failure to reply within the set or extended period for Any reply received by the Office later than three moderned patent term adjustment. See 37 CFR 1.704	E MAILING DATE OF sions of 37 CFR 1.136(a). In no communication. um statutory period will apply and reply will, by statute, cause the anths after the mailing date of this	THIS COMMUNICATION event, however, may a reply be tire d will expire SIX (6) MONTHS from application to become ABANDONE	N. mely filed the mailing date of this communication. ED (35 U.S.C. § 133).			
Status		•				
1) Responsive to communication(s) filed on <u>27 June 2007</u>					
2a)⊠ This action is FINAL.	·					
3) Since this application is in condi	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the p	actice under Ex parte (Q <i>uayle</i> , 1935 C.D. 11, 4	53 O.G. 213.			
Disposition of Claims		•				
4) ⊠ Claim(s) <u>1-6,10 and 12-14</u> is/are 4a) Of the above claim(s) 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) <u>1-6,10 and 12-14</u> is/are 7) □ Claim(s) is/are objected to re	is/are withdrawn from o e rejected. o.	consideration.				
Application Papers		. •				
9) ☐ The specification is objected to be 10) ☐ The drawing(s) filed on 28 Nove Applicant may not request that any Replacement drawing sheet(s) including The oath or declaration is object	mber 2003 is/are: a)⊠ objection to the drawing(suding the correction is req	s) be held in abeyance. Se uired if the drawing(s) is ob	ee 37 CFR 1.85(a). Djected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.						
Attachment(s)	· .					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Revi 3) Information Disclosure Statement(s) (PTO/SE Paper No(s)/Mail Date		4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:	Date			

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DETAILED ACTION

Response to Amendment

The Amendment, filed on June 27, 2007, has been entered and acknowledged by the Examiner. Claims 1-6, 10, and 12-14 are pending in the instant application.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1, 3-6, 10, 12, and 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Isohata et al. (US 6,288,489) in view of Kim et al. (US PUB 2003/0025428).

Regarding claim 1, Ishohata discloses a plasma display device in figures 4 and 5, comprising: a plasma display panel (item 10); and a heat-dissipating plate (item 18), mounted on the plasma display panel and thermally connected to the plasma display panel through a laminar attachment structure (items 1a, 1b, 1c); wherein the laminar attachment structure comprises an annular channel (item 3) which divides the laminar attachment structure into an outer closed portion (area outside of item 3) and an inner portion (inside of item 3) (see FIG. 5C specifically), but does not expressly disclose that at least one vacuum-pumping aperture is formed at the heat-dissipating plate, as claimed by Applicant. The Examiner notes that it is being interpreted that the spacer of Isohata has the same function as the channel of the instant application. A spacer can be defined as a chamber, which is also a channel. Kim is cited to show a plasma display

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device in figure 1 with a plasma display panel (item 10) and a heat-dissipating plate (item 24) with apertures (item 54d) formed. Kim teaches that with the presence of holes in the plate, that the overall area of the plate becomes reduced so that it suffers relatively small pressurizing power (paragraph 55).

Therefore, it would have been obvious to one with ordinary skill in the art at the time the invention was made to modify Isohata's invention to include at least one vacuum-pumping aperture is formed at the heat-dissipating plate as suggested by Kim for reducing the overall area of the plate.

Regarding claim 3, the combined reference of Isohata and Kim disclose the plasma display device of claim 1, wherein the laminar attachment structure is an adhesive double tape (Isohata; column 7, lines 49-52).

Regarding claim 4, the combined reference of Isohata and Kim disclose the plasma display device of claim 1, wherein the inner portion of the laminar attachment structure comprises at least one trench which divides the inner portion into at least two separated regions (Isohata; see FIG. 4, area on item 18).

Regarding claim 5, the combined reference of Isohata and Kim disclose the plasma display device of claim 1, wherein the at least one vacuum-pumping aperture is disposed above the annular channel (Kim; see FIG. 8).

Regarding claim 6, the combined reference of Isohata and Kim disclose the plasma display device of claim 4, wherein the at least one trench of the inner portion of the laminar attachment structure (Isohata; see FIG. 4, area on item 18) communicates with the external

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environment through at least one vacuum-pumping aperture formed at the heat-dissipating plate (Kim; see FIG. 8).

Regarding claim 10, Isohata discloses a plasma display device in figures 4 and 5, comprising: a plasma display panel (item 10); and a heat-dissipating plate (item 18), mounted on the plasma display panel and thermally connected to the plasma display panel through a laminar attachment structure (items 1a, 1b, 1c) having a plurality of strips spaced apart from each other (see FIG. 5C); wherein a respective guide trench (item 3) is disposed between each pair of the neighboring strips to guide out the air within the spaces of the plurality of strips, two ends of at least one guide trench are sealed to form a closed region (area outside of item 3), but does not expressly disclose that at least one vacuum-pumping aperture is formed at the heat-dissipating plate, as claimed by Applicant. The Examiner notes that it is being interpreted that the spacer of Isohata has the same function as the channel of the instant application. A spacer can be defined as a chamber, which is also a channel. Kim is cited to show a plasma display device in figure 1 with a plasma display panel (item 10) and a heat-dissipating plate (item 24) with apertures (item 54d) formed. Kim teaches that with the presence of holes in the plate, that the overall area of the plate becomes reduced so that it suffers relatively small pressurizing power (paragraph 55).

Therefore, it would have been obvious to one with ordinary skill in the art at the time the invention was made to modify Isohata's invention to include at least one vacuum-pumping aperture is formed at the heat-dissipating plate as suggested by Kim for reducing the overall area of the plate.

Regarding claim 12, the combined reference of Isohata and Kim disclose the plasma display device of claim 11, but do not expressly disclose that the space is 3 mm to 20 mm, as

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claimed by Applicant. It would have been obvious to one having ordinary skill in the art at the time the invention was made to have the space between the strips 3 mm to 20 mm, since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art.

Regarding claim 14, the combined reference of Isohata and Kim disclose the plasma display device of claim 10, wherein the laminar attachment structure is an adhesive double tape (Isohata; column 7, lines 49-52).

Claims 2 and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Isohata et al. (US 6,288,489) in view of Kim et al. (US PUB 2003/0025428) in further view of Reisenauer et al. (US 6,161,910).

Regarding claim 2, the combined reference of Isohata and Kim disclose the plasma display device of claim 1, wherein the laminar attachment structure is a thermal pad, as claimed by Applicant. Isohata and Kim both disclose though that the attachment structure may be an adhesive double tape. Reisenauer is cited to show a heat sink (FIG. 4, item 28) that is connected to a display with a thermal pad (FIG. 4, item 84). It would have been obvious to one having ordinary skill in the art at the time the invention was made to have the laminar attachment structure be a thermal pad since it is known in the art that a thermal pad is another way of connecting a heating plate with a display as shown by Reisenauer.

Therefore, it would have been obvious to one having ordinary skill in the art at the time of invention to modify the combined reference of Isohata and Kim to include the laminar

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attachment structure as a thermal pad as suggested by Reisenauer for connecting the display panel and heat dissipating plate.

Regarding claim 13, the combined reference of Isohata and Kim disclose the plasma display device of claim 10, wherein the laminar attachment structure is a thermal pad, as claimed by Applicant. Isohata and Kim both disclose though that the attachment structure may be an adhesive double tape. Reisenauer is cited to show a heat sink (FIG. 4, item 28) that is connected to a display with a thermal pad (FIG. 4, item 84). It would have been obvious to one having ordinary skill in the art at the time the invention was made to have the laminar attachment structure be a thermal pad since it is known in the art that a thermal pad is another way of connecting a heating plate with a display as shown by Reisenauer.

Therefore, it would have been obvious to one having ordinary skill in the art at the time of invention to modify the combined reference of Isohata and Kim to include the laminar attachment structure as a thermal pad as suggested by Reisenauer for connecting the display panel and heat dissipating plate.

Response to Arguments

Applicant's arguments filed June 27, 2007 have been fully considered but they are not persuasive. The Examiner respectfully disagrees with Applicant's arguments. The Examiner first points to figure 5, which shows an annular channel (item 3). Even though Isohata describes the channel as a spacer, it is known that a spacer can be defined as a chamber (i.e. channel). The Examiner is interpreting the spacer of Isohata to have the same function as the channel of the instant application. Regarding Applicant's contention that the Kim reference would have the

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technical features of the present invention, the Examiner disagrees. The Examiner notes that solving the same problem notwithstanding is presumed knowledge of the references, since the references anticipate the claimed subject matter. The prior art clearly teaches the claimed invention, which shows that there would have been a reasonable expectation of success. The Examiner also disagrees with Applicant's arguments regarding the trench of figure 4. As seen in figure 4, the top area of item 18 of Isohata shows a plurality of trenches. Regarding the Reisenauer reference, the Examiner points to the thermal pad, which serves as the laminar attachment structure. Hence, Applicant's claim limitations are met as set forth by the rejection.

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Natalie K. Walford whose telephone number is (571)-272-6012. The examiner can normally be reached on Monday-Friday, 8 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nimesh Patel can be reached on (571)-272-2457. The fax phone number for the organization where this application or proceeding is assigned is (571)-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

nless:

PRIMARY PATENT EXAMINER